



More Precision

interferoMETER // High precision absolute interferometers



Stable thickness measurement with submicrometer resolution interferoMETER 5400-TH

-  Nanometer-accurate thickness measurement, even with varying distances
-  Stable measurement from a long distance
-  Precise thickness measurement of up to 5 layers
-  Measuring rate up to 6 kHz for high speed measurements
-  INTERFACE Ethernet / EtherCAT / RS422 / PROFINET / EtherNet/IP
-  Flexible industrial integration

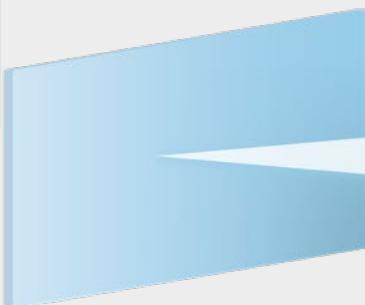
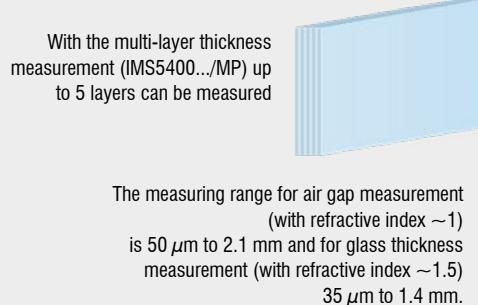


Stable thickness measurement with varying distances

The IMS5400-TH absolute interferometer opens up new perspectives in industrial thickness measurements. The interferometer is used for highly accurate thickness measurements from a relatively large distance. The large thickness measuring range allows the measurement of thin layers, flat glass and films. As the absolute interferometer works with an SLED in the near-infrared range, it is possible to measure the thickness of optically non-dense objects such as anti-reflective coated glass.

Reliable even with vibrating materials

A decisive advantage is the distance-independent measurement, where a stable nanometer-accurate thickness value is achieved. This is how the target can move within the measuring range without influencing the accuracy.



Controller

Model	IMS5400-TH	IMS5400MP-TH
Resolution ^[1]	< 1 nm	
Measuring rate	continuously adjustable from 100 Hz to 6 kHz	
Linearity ^[2]	< ± 100 nm ^[3] / < ± 200 nm ^[4]	
Temperature stability	temperature compensated, stability < 10 ppm between +15 ... +35 °C	
Multi-peak measurement	1 layer	up to 5 layers
Light source	NIR-SLED, narrow wavelength band at approx. 840 nm; pilot laser: laser LED, wavelength 635 nm	
Laser class	Class 1 according to DIN EN 60825-1: 2015-07; Pilot laser: Class 1, power (< 0.2 mW)	
Supply voltage	24 VDC ± 15 %	
Power consumption	approx. 10 W (24 V)	
Signal input	Sync in, trigger in, 2x encoders (A+, A-, B+, B-, index)	
Digital interface	Ethernet / EtherCAT / RS422 / PROFINET ^[5] / EtherNet/IP ^[5]	
Analog output	4 ... 20 mA / 0 ... 10 V (16 bit D/A converter)	
Switching output	Error1-Out, Error2-Out	
Digital output	sync out	
Connection	Optical	Pluggable fiber optic cable via E2000 socket (controller); see accessories for cable lengths; bending radius: static 30 mm, dynamic 40 mm
	Electrical	3-pin supply terminal strip; encoder connection (15-pin, HD-sub socket, max. cable length 3 m, 30 m with external encoder supply); RS422 connection socket (9-pin, Sub-D, max. cable length 30 m); 3-pin output terminal strip (max. cable length 30 m); 11-pin I/O terminal strip (max. cable length 30 m); RJ45 socket for Ethernet (out) / EtherCAT (in/out) (max. cable length 100 m)
Mounting		Free-standing, DIN rail mounting
Temperature range	Storage	-20 ... +70 °C
	Operation	+15 ... +35 °C
Shock (DIN EN 60068-2-27)		15 g / 6 ms in XY axis, 1000 shocks each
Vibration (DIN EN 60068-2-6)		2 g / 20 ... 500 Hz in XY axis, 10 cycles each
Protection class (DIN EN 60529)		IP40
Material		Aluminum housing, passive cooling
Control and indicator elements	Multifunction button: two adjustable functions and reset to factory settings after 10 s; web interface for setup: selectable presets, freely selectable averaging, data reduction, setup management; 6 x color LEDs for intensity, range, SLED, pilot laser, status and power; pilot laser: can be switched on for sensor alignment	

^[1]All data at constant ambient temperature (24 ± 2 °C). Measuring rate 0.5 kHz, moving average over 64 values,
measured differentially between the front and back of a thin glass plate in the mid of the measuring range (2 sigma)

^[2]Maximum deviation from reference system over the entire measuring range, measured on front surface of ND filter

^[3]applies to the IMP TH45 and IMP MP-TH45 sensor models

^[4]applies to the IMP TH70 and IMP MP-TH70 sensor models

^[5]Optional connection via interface module (see accessories)

Sensors for thickness measurements

interferoMETER 5400-TH

TH

Sensors for the IMS5400 controller for thickness measurements

Model	IMP TH45	IMP TH70
Working distance	45 mm ± 3.5 mm	70 mm ± 2.1 mm
Measuring range	Thickness ^[1]	0.035 ... 1.4 mm ^[2]
Temperature stability		Linearity valid for the entire temperature range
Light spot diameter ^[3]	10 μm	5 μm
Measuring angle ^[4]	$\pm 2^\circ$	$\pm 4^\circ$
Connection	Optical	Pluggable fiber optic cable via FC socket (sensor); see accessories for cable lengths; bending radius: static 30 mm, dynamic 40 mm
Mounting		Radial clamping, mounting adapter (see accessories)
Temperature range	Storage	-20 ... +70 °C
	Operation	+5 ... +70 °C
Dimensions	Diameter	Ø10
	Length	30 mm
Protection class (DIN EN 60529)	IP65 / IP40 (option / VAC)	IP65
Vacuum	UHV (cable and sensor)	-
Material		Stainless steel

^[1] Values also for MP measurement

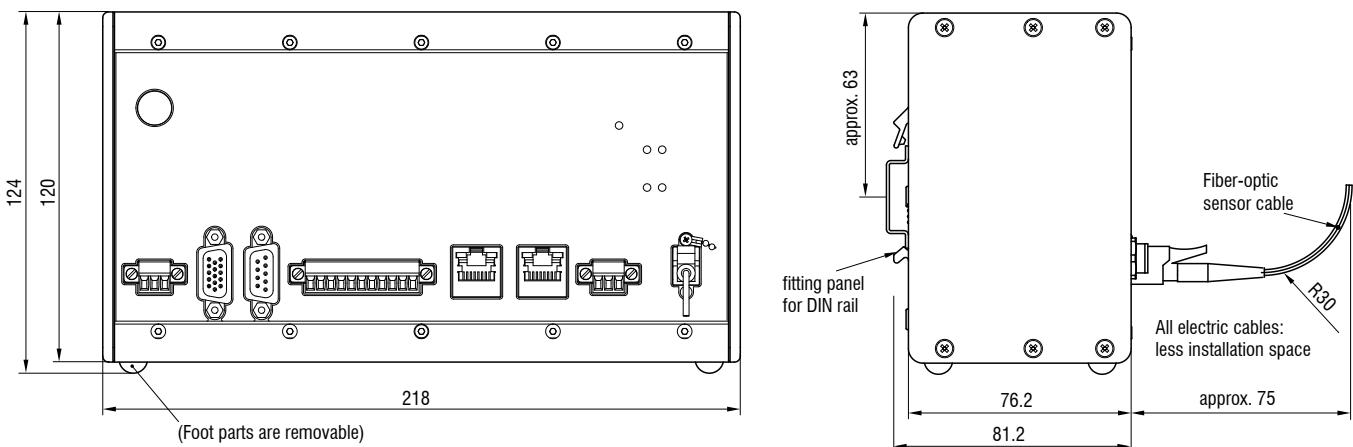
^[2] All data at constant ambient temperature (24 ± 2 °C). Measuring range with n=1.5; for air gap measurement between two glass plates (n~1) the measuring range is 0.05 ... 2.1 mm.
The measuring object must be within the working distance.

^[3] With a working distance of 45 mm (TH-45) or 70 mm (TH-70)

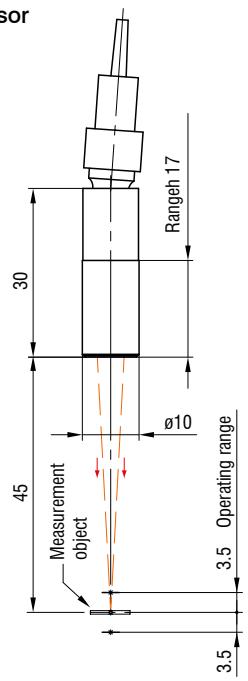
^[4] Maximum sensor tilt angle that produces a usable signal on an approx. 0.6 mm thick BK7 optical flat in the mid of the measuring range.
The accuracy decreases when approaching the limit values.

Dimensions

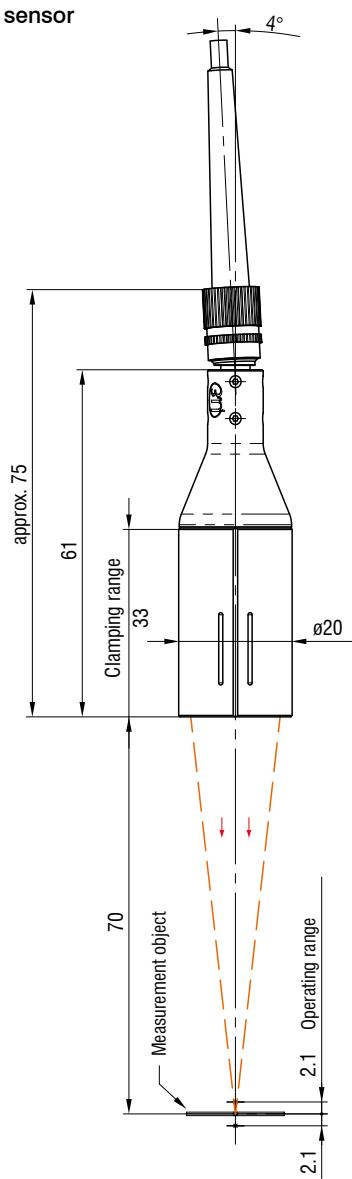
IMS5400-TH controller



Thickness sensor
IMP TH45

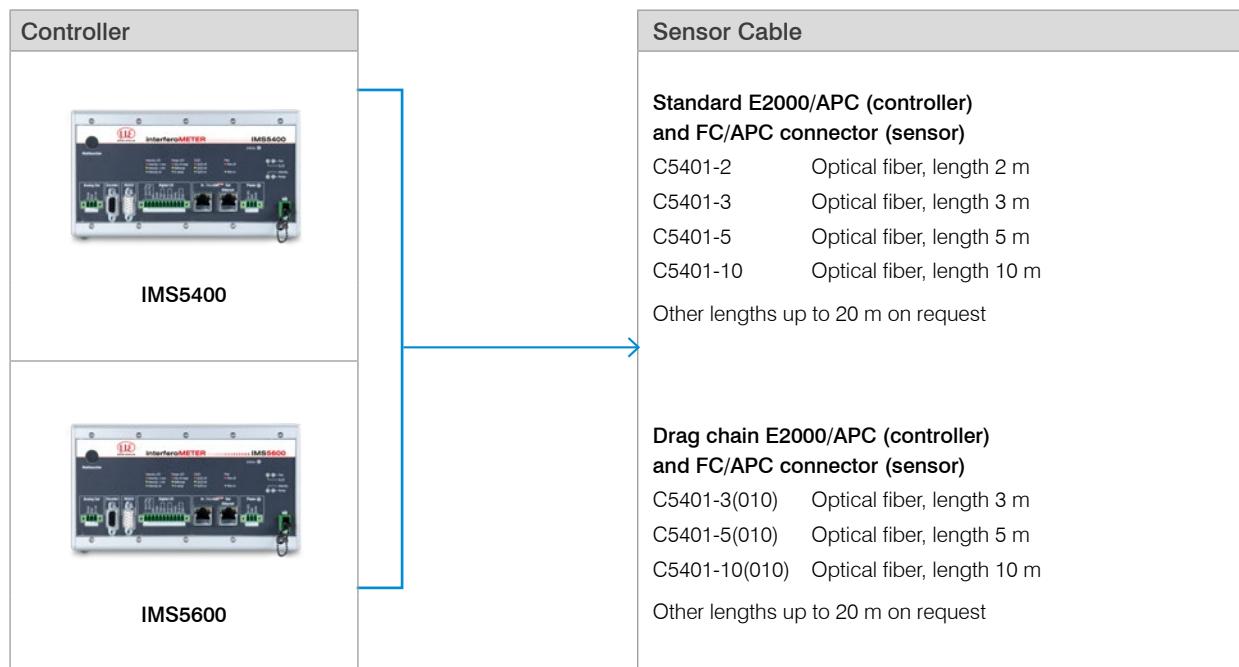


Thickness sensor
IMP TH70

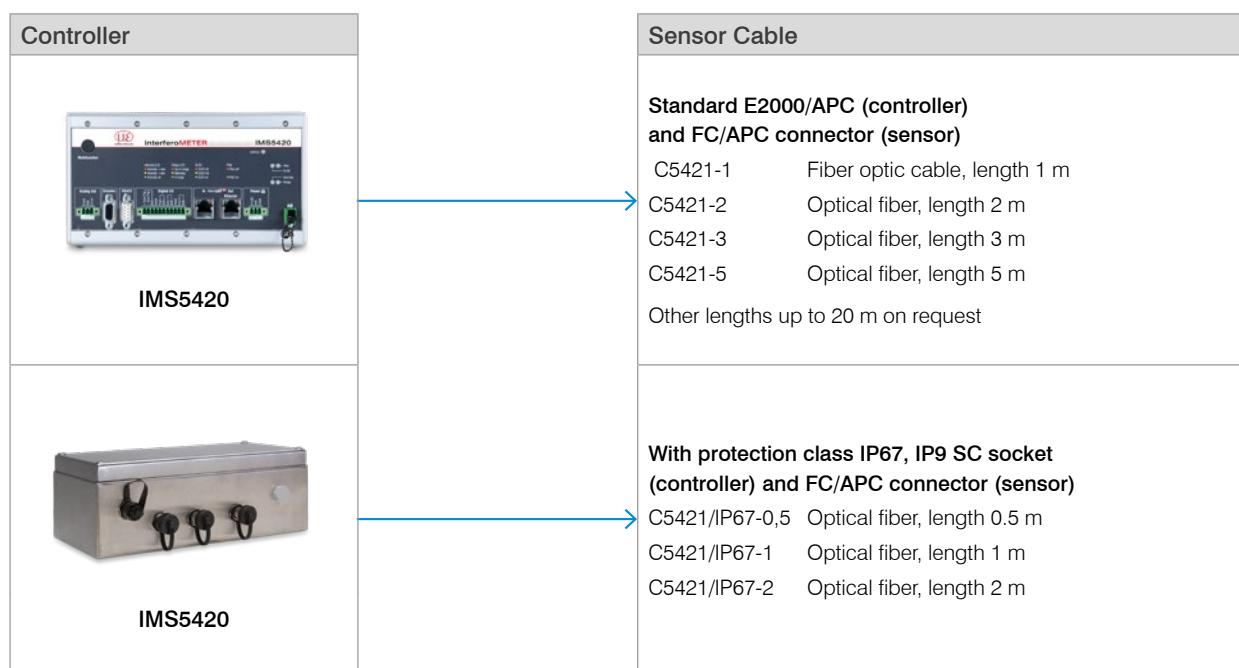


Connection possibilities interferoMETER

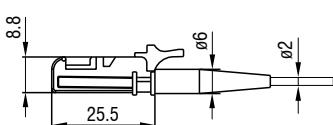
Connection options for the IMS5400 and IMS5600 controllers



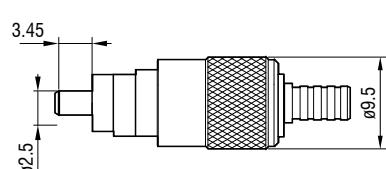
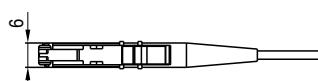
Connection options for the IMS5420 controller



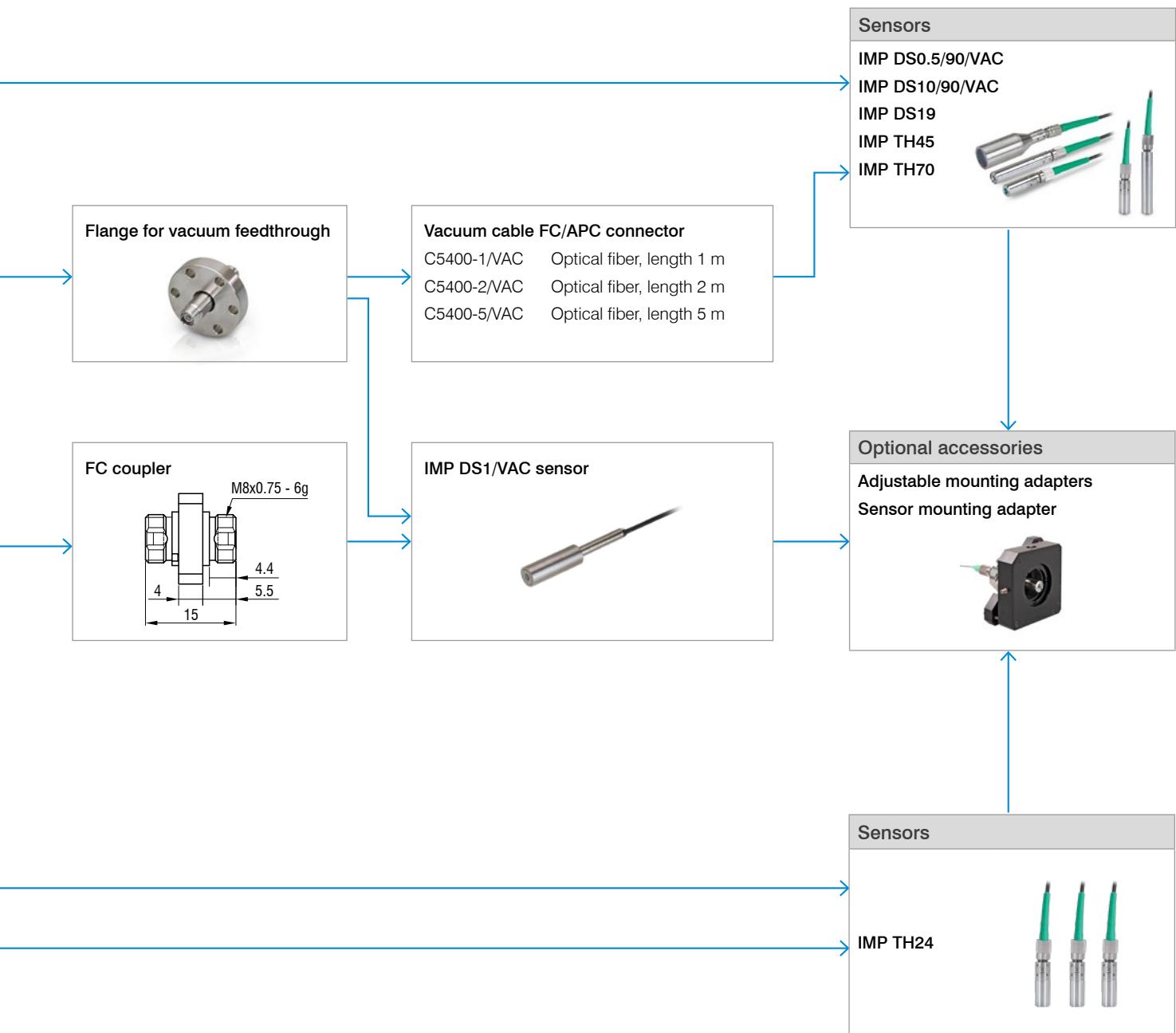
Connector



E2000/APC Standard connector



FC/APC Standard connector



Article designations

DS IMS5xxx-DSxx
 distance measuring system
 (e.g. IMS5600MP-DS19)

IMS5xxx	-DSxx
Controller model	Sensor model
IMS5400	DS1/VAC
IMS5400MP	DS19
IMS5600	DS19/VAC
IMS5600MP	DS0.5/90/VAC DS10/90/VAC

TH IMS5xxx-THxx
 thickness measuring system
 (e.g. IMS5400-TH45/VAC)

IMS5xxx	-THxx
Controller model	Sensor model
IMS5400	TH45
IMS5400MP	TH45/VAC TH70

TH IMS5420xx-THxx
 wafer thickness measuring system
 (e.g. IMS5420-TH24)

IMS5xxx	-THxx
Controller model	Sensor model
IMS5420	TH24
IMS5420MP	TH24(204)
IMS5420IP67	
IMS5420IP67MP	

Optional accessories

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Flange for vacuum feedthrough

C5405/VAC/1/CF16 CF flange

C5405/VAC/1/KF16 KF flange



C5405/VAC/1/CF16
C5405/VAC/1/KF16

Mounting adapter

MA5400-10 Mounting adapter for IMP-DS19/ -TH45

MA5400-20 Mounting adapter for IMP-TH70

MA2402-4 Mounting adapter for IMP-DS1

Other accessories

SC2471-x/IF2008 IMC5400/5600 connector cable+ IF2008/PCIE, length 3 m / 10 m

SC2471-x/RS422/OE IMC5400/5600 interface cable + IF2001/USB, length 3 m / 10 m

IF2001/USB RS422/USB converter

IF2008/PCIE Interface card

IF2035/PNET Interface module for PROFINET integration

IF2035-EIP Interface module for EtherNet/IP with DIN rail housing

PS2020 Power supply 24V / 2.5A

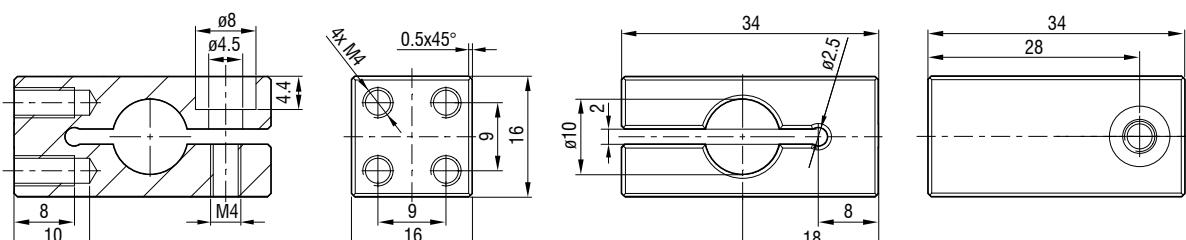
EC2471-3/OE Encoder cable, 3 m

Sensor mounting adapter

MA5400-10

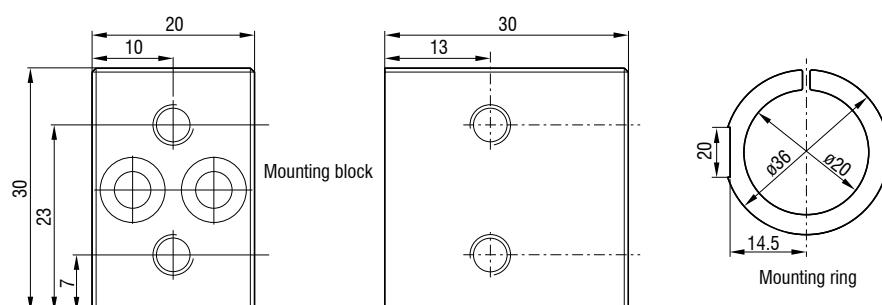
Sensor mounting adapter for all interferoMETER sensors:

(exception IMP-DS1, IMP-TH70)



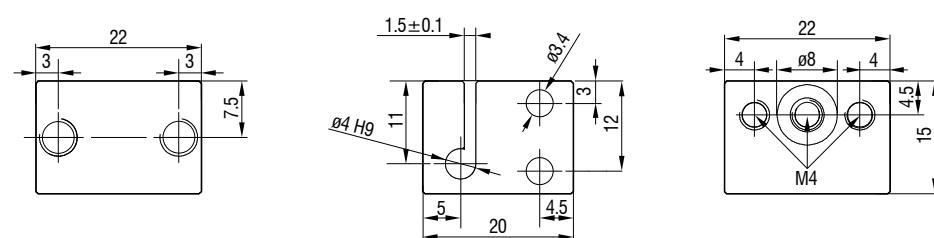
MA5400-20

Sensor mounting adapter for IMP-TH70 sensors:



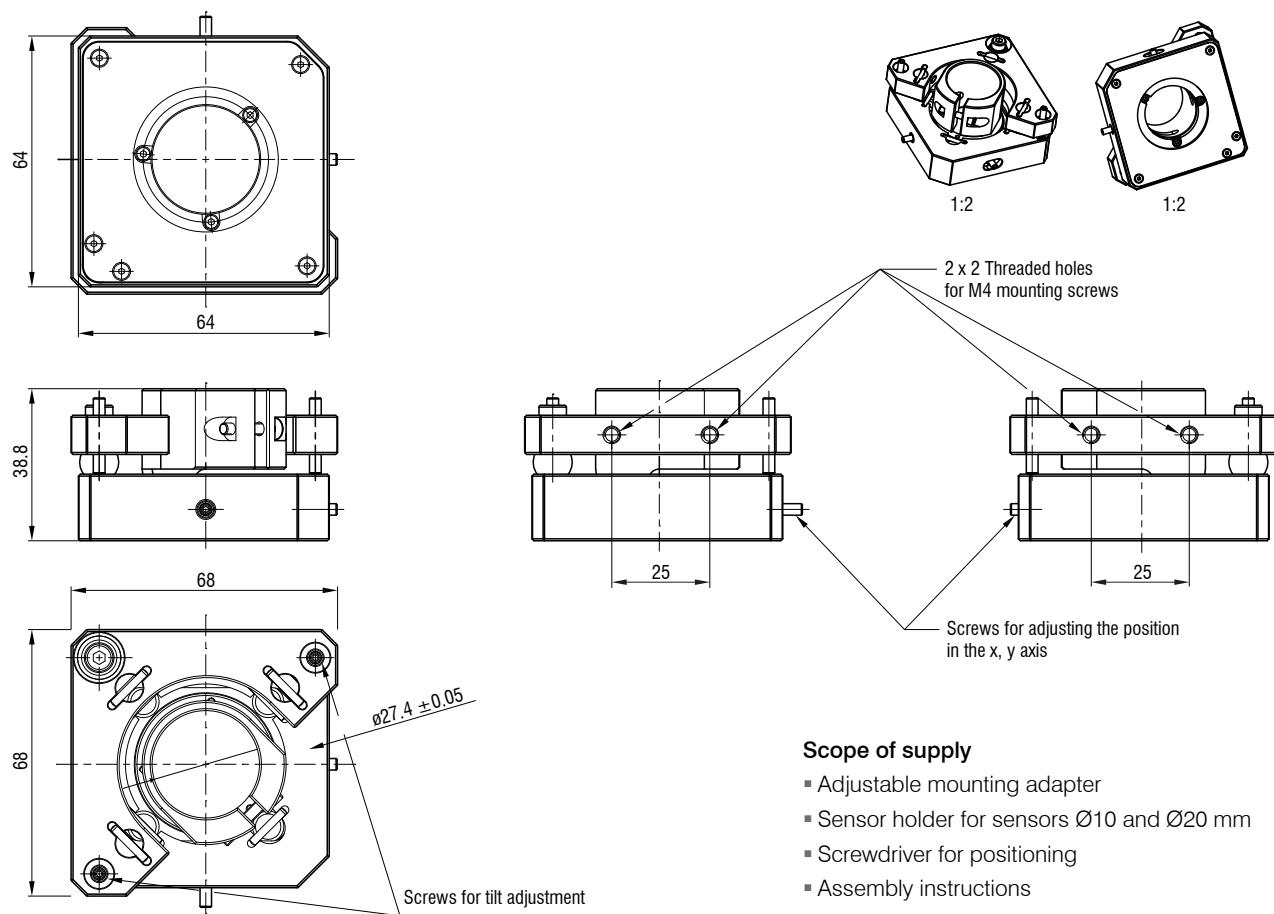
MA2402-4

Sensor mounting adapter for IMP-DS1 sensors



Adjustable mounting adapter

The adjustable JMA mounting adapter simplifies the alignment and fine adjustment of interferometric sensors. The sensors and adapters can be integrated into the machine and aligned directly on site. This corrects, e.g. minor deviations caused by mounting and compensates for tilted measuring objects. With two-sided thickness measurements, the mounting adapter supports the fine alignment of the two measuring points.

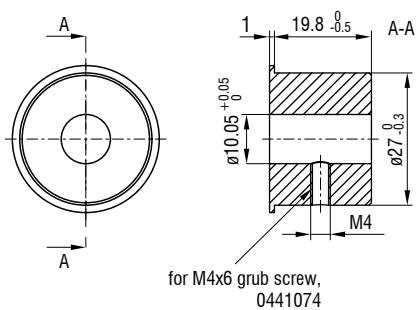


Scope of supply

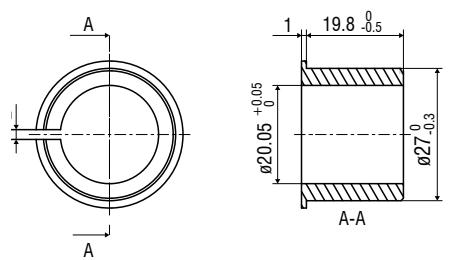
- Adjustable mounting adapter
- Sensor holder for sensors Ø10 and Ø20 mm
- Screwdriver for positioning
- Assembly instructions

Sensor holder

Sensor holder for JMA-10



Sensor holder for JMA-20



(dimensions in mm, not to scale)

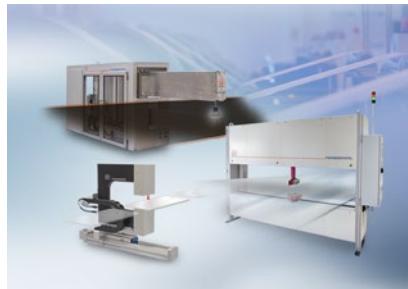
Sensors and Systems from Micro-Epsilon



Sensors and systems for displacement, distance and position



Sensors and measurement devices for non-contact temperature measurement



Measuring and inspection systems for metal strips, plastics and rubber



Optical micrometers and fiber optics, measuring and test amplifiers



Color recognition sensors, LED analyzers and inline color spectrometers



3D measurement technology for dimensional testing and surface inspection